

L Number	Hits	Search Text	DB	Time stamp
1	1	sundar near amartur	USPAT; US-PGPUB; DERWENT	2003/12/06 12:43
2	1	sundar near amartur	EPO; JPO	2003/12/06 12:58
3	4444	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.	USPAT; US-PGPUB; DERWENT	2003/12/06 12:59
4	133	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and (end near point endpoint) and spectr\$ and linear	USPAT; US-PGPUB; DERWENT	2003/12/06 13:12
5	8	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and (end near point endpoint) and spectr\$ and linear near combination	USPAT; US-PGPUB; DERWENT	2003/12/06 13:49
6	732	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and @py>2002	USPAT; US-PGPUB; DERWENT	2003/12/06 13:43
7	37	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and (end near point endpoint) and spectr\$ and linear) and (((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and @py>2002)	USPAT; US-PGPUB; DERWENT	2003/12/06 13:43
8	0	((250/559.27) or (451/5,6,8) or (438/7-9,16) or (216/68,84-85) or (156/345.1-345.16)).CCLS.) and (end near point endpoint) and outside near spectr\$ and linear near combination	USPAT; US-PGPUB; DERWENT	2003/12/06 13:50
9	1	(end near point endpoint) and outside near spectr\$ and linear near combination	USPAT; US-PGPUB; DERWENT	2003/12/06 13:50
-	1	sundar near2 amartur	USPAT; US-PGPUB; DERWENT	2003/06/17 12:39
-	1	sundar near2 amartur	EPO; JPO	2003/06/17 12:47
-	481	linear near2 prediction	EPO; JPO	2003/06/17 12:49
-	86	((linear near2 prediction) same spectr\$2	EPO; JPO	2003/06/17 12:48
-	0	((linear near2 prediction) same spectr\$2) and (wafer semiconductor cmp substrate)	EPO; JPO	2003/06/17 12:49
-	3458	linear near2 prediction	USPAT; US-PGPUB; DERWENT	2003/06/17 12:49
-	880	((linear near2 prediction) same spectr\$2	USPAT; US-PGPUB; DERWENT	2003/06/17 12:49
-	67	((linear near2 prediction) same spectr\$2) and (wafer substrate semiconductor cmp polish\$3)	USPAT; US-PGPUB; DERWENT	2003/06/17 12:51
-	4	((linear near2 prediction) same spectr\$2) and (wafer substrate semiconductor cmp polish\$3) and endpoint	USPAT; US-PGPUB; DERWENT	2003/06/17 12:50
-	23	((linear near2 prediction) same spectr\$2) and (wafer substrate cmp polish\$3)	USPAT; US-PGPUB; DERWENT	2003/06/18 09:48
-	1850	((chemical near2 mechanical near2 polish\$3 cmp) and interference	USPAT; US-PGPUB; DERWENT	2003/06/18 09:50
-	196	((chemical near2 mechanical near2 polish\$3 cmp) and interference) and endpoint	USPAT; US-PGPUB; DERWENT	2003/06/18 09:49
-	261	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)	USPAT; US-PGPUB; DERWENT	2003/06/18 15:14
-	53	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and endpoint	USPAT; US-PGPUB; DERWENT	2003/06/18 10:19

-	239	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)	USPAT; US-PGPUB; DERWENT	2003/06/18 10:19
-	93	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and linear	USPAT; US-PGPUB; DERWENT	2003/06/18 10:19
-	9	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and linear near2 combination	USPAT; US-PGPUB; DERWENT	2003/06/18 10:21
-	0	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and linear near2 prediction	USPAT; US-PGPUB; DERWENT	2003/06/18 11:05
-	0	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and singular near2 decomposition	USPAT; US-PGPUB; DERWENT	2003/06/18 11:08
-	11	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and decomposi\$4	USPAT; US-PGPUB; DERWENT	2003/06/18 11:06
-	0	((chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern)) and (endpoint thickness)) and singular near4 decomposition	USPAT; US-PGPUB; DERWENT	2003/06/18 11:08
-	1489	singular near2 value near2 decomposi\$4 SVD	USPAT; US-PGPUB; DERWENT	2003/06/18 11:10
-	0	parametric near3 linear near3 prediction near3 estimation and resolution	USPAT; US-PGPUB; DERWENT	2003/06/18 11:10
-	0	parametric near3 linear near3 prediction near3 estimation	USPAT; US-PGPUB; DERWENT	2003/06/18 11:10
-	32	linear near3 prediction near3 estimation	USPAT; US-PGPUB; DERWENT	2003/06/18 11:13
-	6	(linear near3 prediction near3 estimation) and resolution	USPAT; US-PGPUB; DERWENT	2003/06/18 11:11
-	3608	linear near3 prediction	USPAT; US-PGPUB; DERWENT	2003/06/18 11:13
-	547	(linear near3 prediction) and resolution and spectr\$3	USPAT; US-PGPUB; DERWENT	2003/06/18 12:41
-	390	((linear near3 prediction) and resolution and spectr\$3) and noise same signal	USPAT; US-PGPUB; DERWENT	2003/06/18 11:15
-	4	((linear near3 prediction) and resolution and spectr\$3) and noise same signal) and wafer	USPAT; US-PGPUB; DERWENT	2003/06/18 11:17
-	20	(linear near3 prediction) and interference near3 (optical pattern)	USPAT; US-PGPUB; DERWENT	2003/06/18 11:25
-	1	((chemical near2 mechanical near2 polish\$3 cmp) and interference) and (linear near3 prediction)	USPAT; US-PGPUB; DERWENT	2003/06/18 11:27
-	58	((chemical near2 mechanical near2 polish\$3 cmp) and interference) and linear same spectr\$3	USPAT; US-PGPUB; DERWENT	2003/06/18 11:28
-	38	(linear near3 prediction) same resolution same spectr\$3	USPAT; US-PGPUB; DERWENT	2003/06/18 14:03
-	4	(linear near3 prediction) same resolution same spectr\$3	EPO; JPO	2003/06/18 14:34

-	558	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and cmp	USPAT; US-PGPUB; DERWENT	2003/06/18 14:39
-	12	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and cmp) and linear near3 (regression combination prediction)	USPAT; US-PGPUB; DERWENT	2003/06/18 14:42
-	18	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and cmp) and linear near3 (regression combination prediction equation)	USPAT; US-PGPUB; DERWENT	2003/06/18 14:42
-	9	(((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and cmp) and linear near3 (regression combination prediction equation)) and resolution	USPAT; US-PGPUB; DERWENT	2003/06/18 14:43
-	4	(chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern) and (fourier near2 deconvolution FSD linear near2 prediction LP lomep)	USPAT; US-PGPUB; DERWENT	2003/06/18 15:18
-	0	(chemical near2 mechanical near2 polish\$3 cmp) and interference near3 (optical pattern) and (fourier near2 deconvolution FSD linear near2 prediction)	USPAT; US-PGPUB; DERWENT	2003/06/18 15:18
-	15	(chemical near2 mechanical near2 polish\$3 cmp) and (fourier near2 deconvolution FSD linear near2 prediction)	USPAT; US-PGPUB; DERWENT	2003/06/18 15:19
-	3	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (fourier near2 deconvolution FSD linear near2 prediction)	USPAT; US-PGPUB; DERWENT	2003/06/18 15:21
-	135	fourier near2 \$deconvolution	USPAT; US-PGPUB; DERWENT	2003/06/18 15:21
-	720	fourier near2 \$deconvolution or fsd	USPAT; US-PGPUB; DERWENT	2003/06/18 15:21
-	7	noise near2 sub-space	USPAT; US-PGPUB; DERWENT	2003/06/18 16:07
-	174	cmp and interference near2 (pattern optical)	USPAT; US-PGPUB; DERWENT	2003/06/18 16:08
-	43	(cmp and interference near2 (pattern optical)) and (fourier or fft)	USPAT; US-PGPUB; DERWENT	2003/06/18 16:09
-	7	((("6556947") or ("6424137") or ("6334807")).PN.	USPAT; US-PGPUB; DERWENT	2003/06/18 16:24
-	10	((("6106662") or ("6161054") or ("6190956") or ("6204922") or ("6334807")).PN.	USPAT; US-PGPUB; DERWENT	2003/06/18 16:25
-	2	("6476921").PN.	USPAT; US-PGPUB; DERWENT	2003/06/18 16:26
-	0	cmp and interference near3 (pattern optical)	EPO; JPO	2003/06/18 16:26
-	1	cmp and interference near3 (pattern optical)	EPO; JPO	2003/06/18 16:27
-	1	chemical near2 mechanical near2 polishing and interference near3 (pattern optical)	EPO; JPO	2003/06/18 16:27

-	44	(US-6415233-\$ or US-5939721-\$ or US-6570662-\$ or US-6567172-\$ or US-6524959-\$ or US-6489624-\$ or US-6375540-\$ or US-6354908-\$ or US-6319093-\$ or US-6309555-\$ or US-6271047-\$ or US-6247998-\$ or US-6201253-\$ or US-6190234-\$ or US-6028669-\$ or US-6024628-\$ or US-6010538-\$ or US-5702982-\$ or US-5372673-\$ or US-5748507-\$ or US-5400265-\$ or US-6348967-\$ or US-6204922-\$ or US-6556947-\$ or US-6424137-\$ or US-6334807-\$).did. or (US-6106662-\$ or US-6476921-\$).did. or (US-20020059047-\$ or US-20030045100-\$ or US-20020173084-\$ or US-20020127950-\$ or US-20020009814-\$ or US-20020001862-\$ or US-20010039064-\$ or US-20010027080-\$ or US-20010021622-\$ or US-20010000497-\$ or US-20020065664-\$).did. or (WO-2074491-\$ or WO-9214997-\$).did. or (WO-200274491-\$ or US-5872633-\$ or US-5748507-\$).did.	USPAT; US-PGPUB; EPO; DERWENT	2003/06/18 16:29
-	3	((US-6415233-\$ or US-5939721-\$ or US-6570662-\$ or US-6567172-\$ or US-6524959-\$ or US-6489624-\$ or US-6375540-\$ or US-6354908-\$ or US-6319093-\$ or US-6309555-\$ or US-6271047-\$ or US-6247998-\$ or US-6201253-\$ or US-6190234-\$ or US-6028669-\$ or US-6024628-\$ or US-6010538-\$ or US-5702982-\$ or US-5372673-\$ or US-5748507-\$ or US-5400265-\$ or US-6348967-\$ or US-6204922-\$ or US-6556947-\$ or US-6424137-\$ or US-6334807-\$).did. or (US-6106662-\$ or US-6476921-\$).did. or (US-20020059047-\$ or US-20030045100-\$ or US-20020173084-\$ or US-20020127950-\$ or US-20020009814-\$ or US-20020001862-\$ or US-20010039064-\$ or US-20010027080-\$ or US-20010021622-\$ or US-20010000497-\$ or US-20020065664-\$).did. or (WO-2074491-\$ or WO-9214997-\$).did. or (WO-200274491-\$ or US-5872633-\$ or US-5748507-\$).did.) and fft	USPAT; US-PGPUB; DERWENT	2003/06/18 16:33
-	20	((US-6415233-\$ or US-5939721-\$ or US-6570662-\$ or US-6567172-\$ or US-6524959-\$ or US-6489624-\$ or US-6375540-\$ or US-6354908-\$ or US-6319093-\$ or US-6309555-\$ or US-6271047-\$ or US-6247998-\$ or US-6201253-\$ or US-6190234-\$ or US-6028669-\$ or US-6024628-\$ or US-6010538-\$ or US-5702982-\$ or US-5372673-\$ or US-5748507-\$ or US-5400265-\$ or US-6348967-\$ or US-6204922-\$ or US-6556947-\$ or US-6424137-\$ or US-6334807-\$).did. or (US-6106662-\$ or US-6476921-\$).did. or (US-20020059047-\$ or US-20030045100-\$ or US-20020173084-\$ or US-20020127950-\$ or US-20020009814-\$ or US-20020001862-\$ or US-20010039064-\$ or US-20010027080-\$ or US-20010021622-\$ or US-20010000497-\$ or US-20020065664-\$).did. or (WO-2074491-\$ or WO-9214997-\$).did. or (WO-200274491-\$ or US-5872633-\$ or US-5748507-\$).did.) and linear	USPAT; US-PGPUB; DERWENT	2003/06/18 16:33
-	4388	((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.	USPAT; US-PGPUB; DERWENT	2003/06/19 09:49

-	968	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp))	USPAT; US-PGPUB; DERWENT	2003/06/19 09:50
-	0	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp)) and linear near2 prediction	USPAT; US-PGPUB; DERWENT	2003/06/19 09:50
-	272	((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp)) and linear	USPAT; US-PGPUB; DERWENT	2003/06/19 09:50
-	0	(((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp)) and linear) and interference	USPAT; US-PGPUB; DERWENT	2003/06/19 09:50
-	76	(((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp)) and linear) and interference	USPAT; US-PGPUB; DERWENT	2003/06/19 11:13
-	3542	((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.	USPAT; US-PGPUB; DERWENT	2003/06/19 11:14
-	0	((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear near3 prediction	USPAT; US-PGPUB; DERWENT	2003/06/19 11:14
-	981	((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear	USPAT; US-PGPUB; DERWENT	2003/06/19 11:14
-	1	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear) and noise near3 space	USPAT; US-PGPUB; DERWENT	2003/06/19 11:15
-	210	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear) and noise	USPAT; US-PGPUB; DERWENT	2003/06/19 11:15
-	78	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear) and noise) and endpoint	USPAT; US-PGPUB; DERWENT	2003/06/19 11:15
-	53	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear) and noise) and endpoint) not	USPAT; US-PGPUB; DERWENT	2003/06/19 11:49
-	178	(((((250/559.27) or (438/7-9,16) or (451/6) or (216/60) or (324/765) or (156/345.1-345.16)).CCLS.) and (polish\$ cmp)) and linear) and interference)	USPAT; US-PGPUB; DERWENT	2003/06/19 11:49
-	15	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.) and linear) and endpoint) and (fourier)	USPAT; US-PGPUB; DERWENT	2003/06/19 14:39
-	140	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.))) and (autoregressive ar)	USPAT; US-PGPUB; DERWENT	2003/06/19 14:39
-	34	(((((451/5-8) or (438/7-9,16) or (216/60,84-85) or (250/559.27)).CCLS.))) and (autoregressive ar)) and endpoint	USPAT; US-PGPUB; DERWENT	2003/06/19 14:39
-	2	("6179691").PN.	USPAT; US-PGPUB; DERWENT	2003/12/06 12:43